=£ UTILITY	Attorney Docket No.	o. 217406US2					
PATENT APPLICATION First Inventor or Application							
TRANSMITTAL  for new nonprovisional applications under 37 CFR 1 53(b))	Title SUBSTRATE PROCESSING SYSTEM AND SUBSTRATE PROCESSING METHOD						
w.	Assignee Name: TOKY	O ELECTRON	LIMITED		2		
	Assignee Address: 3-6	, Akasaka 5-Ch	ome, Minato-Ku, Tok	yo-To, Japan	وكا		
APPLICATION ELEMENTS See MPEP chapter 600 concerning utility patent application contents		Assistant Commissioner for Patents Box Patent Application Washington, DC 20231					
Fee Transmittal Form (e.g. PTO/SB/17) (Submit an original and a duplicate for fee processing)		ACC	COMPANYING APPL	ICATION PARTS	510		
-	Sheets 36	8. <b>E</b> Appli	nment Papers (cover cation Data Sheet. S F.R. §3.73(b) Statem there is an assignee)	ee 37 CFR 1.76			
3. ■ Formal Drawing(s) (35 U.S.C. 113) Total	Sheets 13	10. 🗆 Englis	sh Translation Docum	nent (if applicable)	IDS		
4.	R(S)  initial fiventor(s) named in in. R. \$1.33(d)(2) and  e table or Computer sence Submission  F)  n:  ieies); or  iabove copies  k appropriate box, and sup	State  13.  Prelif  14.  Certif  15.  Appli  16.  Other  Other requisite inti- in-part (CIP)	ment (IDS)/PTO-1448 initiary Amendment e Advance Serial No. ied Copy of Priority or priority is claimed; coff 1.22  Request for Prio  method below: of prior application Group Art  Group Art	Postcard occument(s) (1) ty status. rity  n no.: Unit:			
18. Amend the specification by inserting bet ☐ This application is a ☐ Continuation	fore the first line the s	entence:	ion-in-part (CIP)				
of application Serial No.  Which was published in English  Which was not published in English	Filed on						
☐ This application claims priority of provis	sional application Seri	al No.	Fi	led			
	19. CORRESPONE	DENCE ADDRE	ss				
<b>22850</b> (703) 413-3000							
	FACSIMILÉ: (7						
Name: Marvin J. Spivak			Registration No.:	24,913	$\neg$		
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Attorney Docket No.

217406US2

Signature:

Name:

Docket No. 217406US2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INVENTOR(S) Masanori TATEYAMA, et al.

SERIAL NO: New Application

FILING DATE: Herewith

FOR: SUBSTRATE PROCESSING SYSTEM AND SUBSTRATE PROCESSING METHOD

## FEE TRANSMITTAL

ASSISTANT COMMISSIONER FOR PATENTS

WASHINGTON, D.C. 20231

FOR	NUMBER FILED	NUMBER EXTRA	RATE	CALCULATIONS
TOTAL CLAIMS	20 - 20 =	0	× \$18 =	\$0.00
INDEPENDENT CLAIMS	3 - 3 =	0	× \$84 =	\$0.00
☐ MULTIPLE DEPENDENT CLAIMS (If applicable) + \$280 =				\$0.00
□ LATE FILING OF DECLARATION + \$13			+ \$130 =	\$0.00
	\$740.00			
	\$740.00			
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The Commissioner is hereby authorized to charge any additional fees which may be required for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

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